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PTO/SB/08A (08-00)

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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Complete if Known			
		Application Number			
		Filing Date February 1, 2001			
		First Named Inventor Koichiro TANAKA			
		Group Art Unit			
		Examiner Name			
Sheet	1	of	1	Attorney Docket Number	740756-2256

U.S. PATENT DOCUMENTS						
Examiner Initials ⁵	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
22		5,923,962		Ohtani et al.	07/13/1999	
		5,643,826		Ohtani et al.	07/01/1997	

FOREIGN PATENT DOCUMENTS								
Examiner Initials ⁵	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Office ³	Number ⁴	Kind Code ² (if known)				
22		Japan	10-258383		Kazutaka et al.	09/29/1998		Abstract
22		Japan	07-130652		Fukunaga et al.	05/19/1995		Abstract

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
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Examiner Signature		Date Considered	12/27/02
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Substitute for form 1449A/PTO				<i>Complete if Known</i>	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Application Number	09/774,637
				Filing Date	February 1, 2001
				First Named Inventor	Koichiro TANAKA
				Group Art Unit	2815
				Examiner Name	J. Diaz
				Attorney Docket Number	0756-2256
Sheet	1	of	1		

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		Office³	Number⁴	Kind Code⁵ <i>(if known)</i>			
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		U.S. Patent Application No. 09/741,026, including specification, drawings and filing receipt, "Laser Irradiation Apparatus and Method of Fabricating a Semiconductor Device" Koichiro TANAKA et al., December 21, 2000.	
			

Examiner Signature		Date Considered	12/26/02
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¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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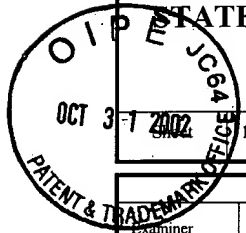
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1 of 1			



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		Number	Kind Code ² (if known)			
7		4,330,363		Biegesen et al.	05/18/82	
2		4,475,027		Pressley	10/02/84	
2		4,733,944		Fahlen et al.	03/29/98	
2		4,974,919		Muraki et al.	12/04/90	
2		5,005,969		Kataoka	04/09/91	
2		5,561,081		Takenouchi et al.	10/01/96	
2		6,100,961		Shiraishi et al.	08/08/00	
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2		6,215,595		Yamazaki et al.	04/10/01	

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D		H. Endert et al., "Excimer Laser: A New Tool for Precision Micromachining," Optical and Quantum Electronics 27, 1995, pp. 1319-1335	
2		H. Hayashi et al., "Fabrication of Low-Temperature Bottom-Gate Poly-Si TFTs on Large-Area Substrate by Linear-Beam Excimer Laser Crystallization and Ion Doping Method," IEDM95, 1995, pp. 829-832	
2		Y. Helen et al., Reproducible High Field Effect Mobility Polysilicon Thin Film Transistors Involving Pulsed Nd:YVO ₄ Laser Crystallization," IEDM99, 1999, pp. 297-300	

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